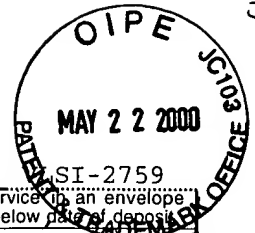


3724



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No.: SI-2759

I hereby certify that this transmittal of the below described document is being deposited with the United States Postal Service in an envelope bearing First Class Postage and addressed to the Assistant Commissioner for Patents, Washington, D.C., 20231, on the below date of deposit.			
Date of Deposit:	05/16/00	Name of Person Making the Deposit:	KATHERINE RINALDI
		Signature of the Person Making the Deposit:	<i>Katherine Rinaldi</i>

#12/lt.re. Filing Divisional
h.morgan
6/7/00

In re Application

Inventor(s): Charles Franklin Drill and Milind Weling

Application No.: 08/824,633

Filed: 03/27/97

Title: A CUSTOMIZED POLISHING PAD FOR SELECTIVE PROCESS PERFORMANCE DURING CHEMICAL MECHANICAL POLISHING

Assistant Commissioner for Patents
Washington, D.C. 20231

NOTIFICATION OF FILING OF DIVISIONAL APPLICATION

☒ Notification is hereby being made of the filing of a divisional application for this case

☒ concurrently herewith.
☐ on

Please direct all correspondence concerning the above-identified application to the following address:

WAGNER, MURABITO & HAO LLP
Two North Market Street, Third Floor
San Jose, California 95113
(408) 938-9060

Respectfully submitted,

Date: 16 May 2000

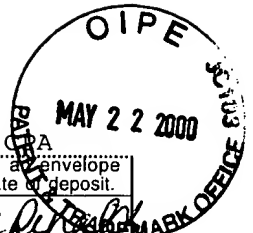
By: *Glenn D. Barnes*
Glenn D. Barnes
Reg. No. 42,293

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MAY 25 2000
TC 3700 MAIL ROOM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No.: VLSI-2759.CRA

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Date of Deposit:	05/16/00	Name of Person Making the Deposit:	KATHERINE RINALDI
		Signature of the Person Making the Deposit:	<i>Katherine Rinaldi</i>



In re Application of:

Inventor(s): Charles Franklin Drill and Milind Weling

Application No.: 08/824,633

Filed: 03/27/97

Title: A CUSTOMIZED POLISHING PAD FOR SELECTIVE PROCESS PERFORMANCE DURING CHEMICAL MECHANICAL POLISHING

Assistant Commissioner for Patents
Washington, D.C. 20231

CONDITIONAL PETITION FOR EXTENSION OF TIME

This conditional petition is being filed along with the accompanying DIVISIONAL and provides for the possibility that applicant has inadvertently overlooked the need for a petition and fee for extension of time.

Conditional petition for extension of time

If any extension of time for the accompanying response is required, applicant requests that this be considered a petition therefor.

Status

This application is on behalf of

- ☒ other than a small entity
☐ a small entity

A verified statement:

- ☐ is attached
☐ is already filed

- [x] The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to Deposit Account No.: 23-0085.
A duplicate copy of this authorization is enclosed.


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MAY 25 2000
TC 3700 MAIL ROOM

Please direct all correspondence concerning the above-identified application to the following address:

WAGNER, MURABITO & HAO LLP
Two North Market Street, Third Floor
San Jose, California 95113
(408) 938-9060

Respectfully submitted,

Date: 16 May 2009

By: 
Glenn D. Barnes
Reg. No. 42,293